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N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

AUG 1 5 2007

Chiharu IRIGUCHI Group Art Unit: 2862

Application No.: 10/790,221 Examiner: R. FULLER

Filed: March 2, 2004 Docket No.: 118580

For: ALIGNER, EXPOSING METHOD, METHOD FOR MANUFACTURING THIN-FILM

TRANSISTOR, DISPLAY DEVICE, AND ELECTRONIC DEVICE USING SHADING

MEANS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection, Notice of Allowance or other action that closes prosecution (e.g., Quayle Action).
 - a. I hereby certify that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. 37 CFR §1.97(e)(1).
- 2. An English language Abstract of one or more non-English language reference is attached. See Reference(s) 1-3.

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- 3. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See Reference(s) 1-3.
- An English language translation of References 2 and 3 is provided.

Respectfully submitted,

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JAO:RMJ/tls

Date: August 15, 2007

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
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Sheet <u>1</u> of <u>1</u>

Form PTO-1449 (REV. 1/06)		CS Dept. of Con	US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 118580			APPLICATION NO. 10/790,221	
INFORMATION DISCLOSURE STATEMENT									
(Use several sheets if necessary)				APPLICANT(S) Chiharu IRIGUCHI					
				FILING DATE March 2, 2004			GROUP 2862		
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Examiner Initials	Cite No.	Document Number	Date		Name				
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FOREIGN PATENT DOCUMENTS									
Examiner Initials	Cite No.	Document Number	Da	nte	Country		With English Abstract	With English Translation	
	1	JP-A 11-233423	08-27-1999		Japan		х	х	
	2	CN 2395299	09-06-2000		China		х	х	
	3	CN 2525562	12-11-2002		China		х	х	
OTHER DOCUMENTS									
Examiner Initials									
EXAMINER						DATE CONSIDERED			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									

Date: August 15, 2007